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16086 U.S. PTO
08/22/03

Mail Stop Patent Application
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Alexandria, VA 22313-1450

PATENT
Attorney Docket No. 008401 02

15535 U.S. PTO
10/646533
08/22/03

In re Application of: **Kenneth S. Collins, Hiroji Hanawa, Kartik Ramaswamy,
Andrew Nguyen, Amir Al-Bayati, Biagio Gallo, and Gonzalo
Antonio Monroy**

Entitled: **PLASMA IMMERSION ION IMPLANTATION PROCESS USING
A PLASMA SOURCE HAVING LOW DISSOCIATION AND LOW
MINIMUM PLASMA VOLTAGE**

Attorney Docket No.: 008401 02

Sir:

Enclosed herewith for filing is a patent application entitled PLASMA IMMERSION ION IMPLANTATION PROCESS USING A PLASMA SOURCE HAVING LOW DISSOCIATION AND LOW MINIMUM PLASMA VOLTAGE including 142 pages of specification, 89 claims and abstract, and 85 sheets of drawings (Figures 1-112).

This application is being filed missing parts and specifically without a declaration by the inventors and without a filing fee. The application is being filed in the names of the inventors, Kenneth S. Collins, Hiroji Hanawa, Kartik Ramaswamy, Andrew Nguyen, Amir Al-Bayati, Biagio Gallo, and Gonzalo Antonio Monroy.

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Dated: August 22, 2003

Respectfully submitted,

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